



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki TAKAIWA et al.

Group Art Unit: 2851

Application No.: 10/587,268

Examiner: M. LIU

Filed: July 26, 2006

Docket No.: 128865

For: IMMERSION EXPOSURE APPARATUS AND DEVICE MANUFACTURING  
METHOD WITH LIQUID DETECTION APPARATUS

**AMENDMENT FILED WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 20, 2009 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, and after entry of the Request for Continued Examination (RCE) filed herewith, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**